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CONFIRMATION NO. 8712

SERIAL NUMBER 10/650,886	FILING OR 371(c) DATE 08/28/2003 RULE	CLASS 134	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. TSM6283131R1
APPLICANTS Horng-Wen Chen, Hsin-Chu, TAIWAN; Chi-How Wu, Tainan, TAIWAN;				
** CONTINUING DATA ***** This application is a REI of 09/669,159 09/25/2000 PAT 6,283,131 <i>gag 6-041</i>				
** FOREIGN APPLICATIONS ***** <i>gag 6-041</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/22/2004				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Allowance <i>gag 6-041</i> Verified and Acknowledged <i>gag 6-041</i> Examiner's Signature Initials		STATE OR COUNTRY TAIWAN	SHEETS DRAWING 6	TOTAL CLAIMS 58
			INDEPENDENT CLAIMS 8	
ADDRESS 25962				
TITLE In-situ strip process for polysilicon etching in deep sub-micron technology				
FILING FEE RECEIVED 1984	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	